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IAP9 Rec'd PCT/PTO 22 MAR 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Shigeki ITO et al.**

Serial Number: **Not yet assigned**  
**(§371 of international application No. PCT/JP2004/014282)**

Filed: **March 22, 2006**

For: **ANTISTATIC GLASS SUBSTRATE PRODUCTION METHOD AND  
ANTISTATIC GLASS SUBSTRATE PRODUCED BY THE METHOD**

Attorney Docket Number: **062258**  
Customer Number: **38834**

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

March 22, 2006

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. A copy of each non- U.S. document is enclosed herewith as well as an International Search Report mailed January 11, 2005.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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SGA/mc

Enclosure: PTO/SB/08, Documents (5) & Int'l Search Report

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Combined Form PTO/SB/08A&B				<i>Complete if Known</i>	
<b><u>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</u></b>				Application Number	Not yet assigned
				Confirmation Number	
				Filing Date	March 22, 2006
				First Named Inventor	Shigeki ITO et al.
				Art Unit	
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	062258

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

## **NON PATENT LITERATURE DOCUMENTS**

NON-PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>6</sup>
	5	HARUHISA FUJII, "Control of Charge on Insulating Glass in Vacuum by Plasma Processing", IEEE Transaction on Dielectrics and Electrical Insulation 2002, Vol. 9, No. 2, pages 230-235	
	6	International Search Report of International Application PCT/JP2004/014282 mailed January 11, 2005	

**Examiner Signature** \_\_\_\_\_ **Date Considered** \_\_\_\_\_

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kind Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov), MPEP 901.04 or in the comment box of this document. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to indicate here if English language Translation is attached.